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STATEMENT BY APPLICANT NOT YET ASSIGNED Art Unit (Use as many sheets as necessary) NOT YET ASSIGNED **Examiner Name** Attorney Docket Number N1085-00154 Sheet 1 of 13

			U. S. PATENT		
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ^{2 (f known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Cotumns, Lines, Where Relevant Passages or Relevant Figures Appear
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	FOREIGN PATENT DOCUMENTS							
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		NON PATENT LITERATURE DOCUMENTS					
Examin Initials*		Cite Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of					
W/	RB	SHU-KAI S ET AL., "Siso Run-To-Run Controller Using Tripple EWMA Smoothing," Pages 1-9, Taiwan					
	С	TELFEYAN ET AL., "A Multi-Level Approach To The Control Of A Chemical-Mechanical Planarization Process," Pages 1- 20, U.S.A.					
	D	TELFEYAN ET AL., "Demonstration Of A Process-Independent Run-To-Run Controller, Pages 1-11. U.S.A.					
	E	HERZOG ET AL., "Preconditions And Strategies For Successful Implementation Of Advanced Process Control On A Large Scale, Pages 83-88, Germany					
	F	TSAKALIS ET AL. "The Role Of Dead-Zones In Improving Run-To-Run Control Performance," Pages 1-15, AEC/APC Symposium XI, Vail, Sept. 12-17, 1999, U.S.A.					
	G	HARDT ET AL., "Cycle To Cycle Manufacturing Process Control," Pages 1-9, U.S.A.					
	H CAMPBELL ET AL., "Run-To-Run Control of Photolithography Processes", P. 7/1/2001, Future Fab Volume 10, KLA-Tencor, U.S.A., http://www.future-fab.com/documents.asp2d_ID=1152_cited_5/15/2003						
MOYNE, "Run By Run Control: Interfaces, Implementation, and 1-2, February 1995, CIDM Memo 95-12, Last Updated 11/6/19		MOYNE, "Run By Run Control: Interfaces, Implementation, and Integration,", Pages 1-2, February 1995, CIDM Memo 95-12, Last Updated 11/6/1996, U.S.A., http://www-mtl.mit.edu/CIDM/memos/95-12/95-12 html, cited 5/15/2003					
	J	Chapter 3, "Principal Components Analysis," Pages 1-41, U.S.A.					
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		NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
XX	L	CROW, "Improving Overlay Performance In Lithography Tools Using Run-To-Run Control, New Vision Systems, Pages 1-13, U.S.A., http://www.micromagazine.com/archive/03/01/crow.html , cited 5/15/2003				
	М	BALIGA, "Advanced Process Control: Soon To Be A Must, Semiconductor International July 1999, Pages 1-9, U.S.A. MOYNE ET AL., Project M6: RMS In The Semiconductor Industry, Pages 1-2, U.S.A., http://erc.engin.umich.edu/M6.htm, cited 5/15/2003				
	N					
O P Q		MOYNE ET AL., Run-To-Run Control, Updated: Friday 21-April-2000, U.S.A., http://www.eecs.umich.edu/~impact/Research/R2R.html, cited 5/15/2003				
		Principal Component Analysis (tutorial), Pages 1-2, March 23, 1999, U.S.A., http://www.fon.hum.uva.nl/praat/manual/Principal_component_analysis.html, cited 6/9/2003				
		6.5.5.1. "Properties Of Principal Components," Engineering Statistics Handbook, Pages 1-7, U.S.A., http://www.itl.nist.gov/div898/handbook/pmc/section5/pmc551.htm, cited 6/10/2003				
	R	HyperStat Online Contents, "Computing Pearson's Correlation Coefficient," Pages 1-2, U.S.A., http://davidmlane.com/hyperstat/A51911.html, cited 6/13/2003				
	s	TexaSoft's Statistics Tutorial - "Pearsons Correlation Coefficient," Pages 1-3, Copyright TexaSoft, 1996-2001, U.S.A., http://www.texasoft.com/winkpear.html, cited 6/13/2003				
V	Т	Component Scores & Their Uses, Pages 1-3				
						

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